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CONFIRMATION NO. 3229

SERIAL NUMBER 10/027,882	FILING DATE 12/21/2001 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. A0-001-2D
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APPLICANTS

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**** CONTINUING DATA *******

This application is a DIV of 10/032,198 12/20/2001
 which is a CIP of 09/865,981 05/24/2001 PAT 6,483,962
 which claims benefit of 60/206,744 05/24/2000
 and claims benefit of 60/241,269 10/17/2000 *SA 9/1/04*
 and said 10/032,198 12/20/2001
 claims benefit of 60/206,744 05/24/2000

**** FOREIGN APPLICATIONS ******* *"NONE"*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** SMALL ENTITY **
**** 02/15/2002**

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY CA	SHEETS DRAWING 27	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 2
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Verified and Acknowledged
 Examiner's Signature *[Signature]* Initials *SA*

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TITLE
 Deep-well lithography process for forming micro-electro-mechanical structures

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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